In re the Application of: Tadashi WATANABE et al.

Art Unit: 2818

Application Number: 10/823,729

Examiner: David Vu

Filed: April 14, 2004

Confirmation Number: 5344

For: SEMICONDUCTOR DEVICE FABRICATION METHOD

Attorney Docket Number: 042341

Customer Number: 38834

## AMENDMENT UNDER 37 C.F.R. §1.111

Mail Stop: Amendment Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

May 27, 2008

Sir:

This paper is filed in response to the Office Action dated January 25, 2008.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 7 of this paper.